

<b>Notice of References Cited</b>	Application/Control No. 10/554,172		Applicant(s)/Patent Under Reexamination MUGICA MIGUEL ET AL.	
	Examiner Tam Nguyen		Art Unit 3764	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,932,651	06-1990	Defaux, Georges	482/61
*	B	US-6,004,243	12-1999	Ewert, Bruce	482/8
*	C	US-5,547,382	08-1996	Yamasaki et al.	434/61
*	D	US-3,905,597	09-1975	Tabb, Lester M.	482/61
*	E	US-4,750,737	06-1988	Smith, Sebie B.	482/61
*	F	US-D273,882	05-1984	Bryne, Richard M.	D21/664
*	G	US-4,955,600	09-1990	Hoffenberg et al.	482/61
*	H	US-4,082,265	04-1978	Berkes, James R.	482/61
*	I	US-7,060,009	06-2006	Greenleaf, Mark Stanley	482/61
*	J	US-6,932,750	08-2005	Dorner, Michael W.	482/142
*	K	US-5,035,233	07-1991	Ruf, Hermann	601/27
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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